

INFORMATION DISCLOSURE CITATION:

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Page 1 of 3

007272-000053.305503

Atty. Docket No.: 7272-53

Serial No.: 10/822,619

Applicant Han Nee

Filing Date: April 12, 2004

Group Art: 1774

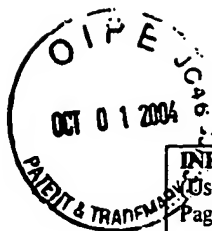
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Examiner Initial	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	Filing Date If appropriate
<i>SP</i>	6,790,503	09/14/04	Nee			
	* 6,232,036	05/15/01	Suzuki et al.			
	* US 2003/0180495 A1	09/25/03	Ito et al.			
	* US 2003/0215598 A1	11/20/03	Nee			
	* 4,404,656	9/13/83	Cornet et al.			
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	* 4,450,553	5/22/84	Holster et al.			
	* 4,709,363	11/24/87	Dirks et al.			
	* 4,998,239	3/5/91	Strandjord et al.			
	* 5,090,009	2/18/92	Hamada et al.			
	* 5,093,174	3/3/92	Suzuki et al.			
	* 5,171,392	12/15/92	Iida et al.			
	* 5,325,351	6/28/94	Uchiyama et al.			
	* 5,391,462	2/21/95	Arioka et al.			
	* 5,415,914	5/16/95	Arioka et al.			
	* 5,419,939	5/30/95	Arioka et al.			
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	* 6,007,889	12/28/99	Nee			
	* 6,280,811	08/28/01	Nee			
	* 6,451,402	09/17/02	Nee			
	* 5,853,872	12/29/98	Shimamori et al.			
	* 5,753,413	05/19/98	Nishida et al.			
	* 5,948,497	09/07/99	Hatwar et al.			
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Page 2 of 3

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Page 3 of 3

Any. Docket No.: 7272-53

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*		04-176039	06/23/92	JP				
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*	English Translation of JP Publication No. 10-011799
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Examiner

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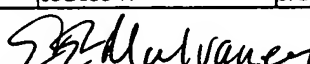
INFORMATION DISCLOSURE CITATION		Atty. Docket No.: 7272-53		Application No.: 10/822,619		
Page 1 of 4 Pages						
7272-53/312402		Applicant: Han H. Nee				
		Filing Date: April 12, 2004		Group Art Unit: 1774		
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* US2002/0034603	03/21/02	Nee				
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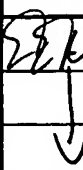

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Page 2 of 4 Pages 7272-53/312402				Applicant: Han H. Nee			
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Page 3 of 4 Pages 7272-53/312402				Applicant : Han H. Nee				
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Page 4 of 4 Pages 7272-53/312402				Applicant: Han H. Nee					
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	*	05195011	2/21/95	JP					
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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s) publisher city and/or country where published	²
		Kirk-Othmer, Encyclopedia of Chemical Technology, 3 rd Ed., Vol. 10, pp. 247-283	
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